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EXPEDITED PROCEDURE
Art Unit 2812

Docket No.: 29936/39764
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Cha Deok Dong

Application No.: 10/720,457 Confirmation No.: 4077

Filed: November 24, 2003 Art Unit: 2812

For: METHOD FOR FORMING DEVICE
ISOLATION FILM IN SEMICONDUCTOR
DEVICE Examiner: M. M. Trinh

AMENDMENT "C" AFTER FINAL ACTION

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the official action dated October 9, 2007, finally rejecting claims 1-14, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.